# Optimized Terminal Current Calculation for Monte Carlo Device Simulation

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Abstract—We present a generalized Ramo–Shockley theorem (GRST) for the calculation of time-dependent terminal currents in multidimensional charge transport calculations and simulations. While analytically equivalent to existing boundary integration methods, this new domain integration technique is less sensitive to numerical error introduced by calculations of finite precision. Most significantly, we derive entirely new optimized formulas for the ensemble Monte Carlo estimation of steady-state terminal currents from the time-independent form of our GRST, which are in general not equivalent to the time-average of the true time-dependent terminal currents. We then demonstrate, both analytically and by means of example, how our new variance-minimizing terminal current estimators may be exploited to improve estimator accuracy in comparison to existing methods.

## I. INTRODUCTION

THE simplest method which may be used to calculate terminal currents within Monte Carlo charge transport simulations is particle counting. That is, every particle which enters or leaves a contact is tallied as flux through that contact. This type of estimator tends to converge very slowly because of the relative rarity of boundary crossing events, a problem which is exacerbated by modern highly doped contacts in which the mean carrier velocity is only a small fraction of the thermal velocity. An analogous problem arises in moment-based simulation methods from the errors associated with numerical differentiation in highly doped contact regions [1], [2]. Simply displacing the boundary surface along which contact current is calculated outwards from the high doping regions can provide a partial solution for momentbased simulation in some circumstances [3], but does not fully address the fundamental problem for particle-based Monte Carlo simulations. Considerably better convergence may be obtained by calculating the exact instantaneous current densities  $J_n$ ,  $J_p$ , and  $J_d$ , and integrating this result along the contact boundary. This method, although very straightforward, has the disadvantage of relying heavily on the accuracy of the numerical solution on only a few grid nodes. Furthermore, as we will see, if steady-state terminal currents are our goal, there are better Monte Carlo estimators than the time-average of the true terminal currents. We offer a brief historical digression to motivate these thoughts.

The original domain integration method for terminal currents comes from the work of Shockley [4] and Ramo [5]

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based on a Green's function technique. The Ramo–Shockley theorem has since been restated for multiple charge carriers [6] based on the linearity of Maxwell's equations and separately using energy balance arguments. For the total current through contact k, the final result is [4]–[6]

$$I_k = \sum_i q_i \mathbf{W}_k(\mathbf{r}_i) \cdot \mathbf{v}_i \tag{1}$$

where the summation is over all charges i within the domain and  $\mathbf{v}_i$ ,  $\mathbf{r}_i$ , and  $q_i$  are the velocity vector, position vector, and the charge of the *i*th particle, respectively.  $\mathbf{W}_k(\mathbf{r})$  is the electric field generated by removing all charges from the domain and grounding all contacts except for contact k which is set to 1 V. Although this result was derived under the assumption of constant contact potentials, an additional term may be added to (1) to account for their time dependence [7]. By integrating particle velocity over the entire device domain, the Ramo-Shockley theorem overcomes the previously mentioned numerical weakness of boundary integration schemes. In the general case of transients and/or generation/recombination processes, however, the Ramo-Shockley theorem offers no straightforward way to distinguish between the electron, hole, and displacement contributions to the total terminal current. It will easily be seen that the Ramo-Shockley domain integral formulation of terminal currents is a special case of a more general technique introduced by Mock [8] and Gajewski [9] based on the concept of "weak solutions," which may be used to overcome this disadvantage. In the following analysis, we make use of this test function method to derive general expressions for the time-dependent electron, hole, displacement, and total current at arbitrary contacts.

We show that the *time-independent* form of these generalized Ramo–Shockley theorem (GRST) expressions leads to a new class of estimators for steady-state terminal current, not generally equivalent to the time-average of the true terminal currents. We then derive the defining equations for a set of optimized test functions which, in conjunction with the new terminal current estimator formulas, lead to minimumvariance estimators for steady-state terminal currents in ensemble particle-based simulation. Finally, we provide an application of our method demonstrating its improved convergence properties.

#### II. GENERALIZED RAMO-SHOCKLEY THEOREM

From the Poisson and Boltzmann transport equations, we have on the Lipschitzian domain  $\Omega$ 

$$-\nabla \cdot \mathbf{j}_n = eG_n(\mathbf{r}) - e\dot{n} \tag{2}$$

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$$-\nabla \cdot \mathbf{j}_p = -eG_p(\mathbf{r}) + e\dot{p} \tag{3}$$

$$-\nabla \cdot \epsilon \nabla \psi = e(f - n + p). \tag{4}$$

Current relations are in general  $\mathbf{j}_n = -en\langle \mathbf{v}_n \rangle$ ,  $\mathbf{j}_p = ep\langle \mathbf{v}_p \rangle$ . The symbol  $\langle \cdot \rangle$  denotes ensemble average, and the variables n, p, and  $\psi$  are the electron and hole densities and the electrostatic potential. The symbols  $\epsilon, t, \mathbf{r}, e, f$  refer to the dielectric permittivity, time, space coordinate vector, fundamental electronic charge, and net ionized impurity number density, respectively.

Differentiation of (4) with respect to time yields another equation which involves displacement current

$$-\nabla \cdot \mathbf{j}_d = \nabla \cdot \epsilon \nabla \dot{\psi}.$$
  
=  $-e(\dot{p} - \dot{n}) = \nabla \cdot (\mathbf{j}_n + \mathbf{j}_p).$  (5)

For each of the currents  $\mathbf{j}_n$ ,  $\mathbf{j}_p$ , and  $\mathbf{j}_d$ , we have an equation of the form

$$-\nabla \cdot \mathbf{j}_k = R_k, \quad k = n, p, d, \text{tot}, \quad \mathbf{j}_{\text{tot}} = \mathbf{j}_n + \mathbf{j}_p + \mathbf{j}_d \quad (6)$$

where  $\mathbf{j}_{\text{tot}}$  denotes the total current. Let  $H^1(\Omega)$ ,  $H^1_0(\Omega)$  denote the usual Hilbert spaces and let  $n, p, \psi \in H^1$ , and  $h_{kl}$  be a set of suitable test functions

$$h_{kl}|_{\Gamma_l} = 1, \quad h_{kl}|_{\Gamma_j} = 0, \quad j \neq l, \quad h \in H^1, \quad k = n, p, d, t.$$
(7)

The boundary  $\Gamma$  may consist of both Neumann and Dirichlet parts,  $\Gamma = \Gamma_N \cup \Gamma_D$ , with  $\Gamma_D = \bigcup_i \Gamma_i$  and  $\Gamma_D$  having positive surface measure. Multiplication of each equation of type (6) by the test function  $h_{kl}$  yields by integration by parts [8], [9]

$$(-\nabla \cdot \mathbf{j}_{k}, h_{kl}) = (R_{k}, h_{kl})$$
$$-\int_{\Omega} h_{kl} \nabla \cdot \mathbf{j}_{k} \, dV = -\int_{\Gamma} h_{kl} \mathbf{j}_{k} \cdot d\mathbf{S} + \int_{\Omega} \nabla h_{kl} \cdot \mathbf{j}_{k} \, dV. \quad (8)$$

The choice of  $h_{kl}$  ensures that the surface integral at the righthand side is the surface integral over the contact current (due to  $h_{km}|_{\Gamma_l} = \delta_{ml}$ ;  $(\mathbf{j}_k \cdot \hat{\mathbf{n}})|_{\Gamma_N} = 0$ ). A similar test function technique has already found application in the calculation of capacitances in complex wiring structures [10].

From (2), (3), (5), and (8), the following simple equations result for the terminal currents at an arbitrary contact l:

$$I_{nl} = \int \nabla h_{nl}(\mathbf{r}) \cdot \mathbf{j}_n \, dV + e \int \dot{n} h_{nl}(\mathbf{r}) \, dV$$
  
$$- e \int G_n(\mathbf{r}) h_{nl}(\mathbf{r}) \, dV \qquad (9)$$
  
$$I_{pl} = \int \nabla h_{pl}(\mathbf{r}) \cdot \mathbf{j}_p \, dV - e \int \dot{p} h_{pl}(\mathbf{r}) \, dV$$
  
$$+ e \int G_p(\mathbf{r}) h_{pl}(\mathbf{r}) \, dV \qquad (10)$$

$$I_{dl} = \int \nabla h_{dl}(\mathbf{r}) \cdot \mathbf{j}_d \, dV - \int h_{dl}(\mathbf{r}) \nabla \cdot (\mathbf{j}_n + \mathbf{j}_p) \, dV$$
$$= \int \nabla h_{dl}(\mathbf{r}) \cdot \mathbf{j}_d \, dV + e \int (\dot{p} - \dot{n}) h_{dl}(\mathbf{r}) \, dV \qquad (11)$$

$$I_{tl} = \int \nabla h_{tl}(\mathbf{r}) \cdot (\mathbf{j}_n + \mathbf{j}_p + \mathbf{j}_d) \, dV.$$
(12)

for which we wish to emphasize that the choice of test functions for each of the four above equations may be made independently. This set of equations provides a powerful tool for examining the various contributions to each of the time-dependent terminal currents for multidimensional device topologies.

That the identity  $I_{tl} = I_{nl} + I_{pl} + I_{dl}$  holds in general for (9)–(12) is a result of the properties of solutions to the defining transport equation, rather than a direct consequence of (9)–(12) themselves. Importance sampling schemes for particle-based simulation, which often "microscopically" disturb conservation laws implicit in transport equations, may also disturb the identity  $I_{tl} = I_{nl} + I_{pl} + I_{dl}$  if particle redistribution is performed between evaluations of any of the terminal current formulas.

## III. REDUCTION OF NUMERICAL ERROR IN MOMENT-BASED SIMULATION

Gajewski's implementation of test functions took the following form:

$$-\nabla \cdot \nabla \hat{h}_{Gl} = 0, \quad \hat{h}_{Gl}|_{\Gamma_i} = 1 + \delta, \hat{h}_{Gl}|_{\Gamma_j} = -\delta, \quad j \neq l, \delta \ge 0$$
(13)

and  $h_{Gl}$  is defined as

$$h_{Gl} = P_3(\Theta(\hat{h}_{Gl})), \quad P'_3(0) = 0,$$
  
 $P'_3(1) = 0, \quad P_3(0) = 0, \quad P_3(1) = 1$ 

with  $\Theta$  defined as the unit step function, and  $P_3(x)$  defined as a third-degree polynomial. Note the similarity between De Visschere's  $\mathbf{W}_l$  in (1) and  $-\nabla \hat{h}_{Gl}$  above. Gajewski's actual test functions  $h_{Gl}$ , however, are more generally useful for purposes of numerical simulation due to their vanishing gradient near contact regions for  $\delta > 0$ , and their smoothness arising from the properties of  $P_3(x)$ . While one can most often choose a  $\delta$  for which this technique eliminates contributions to the terminal currents from undesired regions, it may also simultaneously neglect useful regions. Working in the context of total current, Mock [8] proposed another defining equation

$$\nabla \cdot \sigma \nabla h_M = 0 \tag{14}$$

where  $\sigma$  is the electrical conductivity plus  $\epsilon/\Delta t$ . This form involves no adjustable parameter and its solution exhibits qualitatively good properties for application in moment-based simulation.

## IV. STEADY-STATE TERMINAL CURRENT ESTIMATORS

General expressions for steady-state terminal currents may be derived from (9)–(12) by taking their expectation values with respect to time, setting all time derivatives equal to zero

$$\bar{I}_{nl} = (\bar{\mathbf{j}}_n, \nabla h_{nl}(\mathbf{r})) - (e\bar{G}_n(\mathbf{r}), h_{nl}(\mathbf{r}))$$
(15)

$$I_{pl} = (\mathbf{j}_p, \nabla h_{pl}(\mathbf{r})) + (eG_p(\mathbf{r}), h_{pl}(\mathbf{r}))$$
(16)



Fig. 1. Simulated free electron density for a 40-nm LDD NMOS transistor.



Fig. 2. Scalar electron current density variance tensor in units of  $2.56 * 10^{-4} \text{A}^2/\text{cm}^4$ .

$$\bar{I}_{dl} = 0 \tag{17}$$

$$\bar{I}_{tl} = (\bar{\mathbf{j}}_n + \bar{\mathbf{j}}_p, \nabla h_{tl}(\mathbf{r})).$$
(18)

In particle-based simulation, one may employ the following unbiased *estimators* for the steady-state terminal currents:

$$\hat{I}_{nl} = \left(\hat{\mathbf{j}}_n, \nabla h_{nl}(\mathbf{r})\right) - \left(e\hat{G}_n(\mathbf{r}), h_{nl}(\mathbf{r})\right)$$
(19)

$$\bar{I}_{pl} = \left(\bar{\mathbf{j}}_{p}, \nabla h_{pl}(\mathbf{r})\right) + \left(e\bar{G}_{p}(\mathbf{r}), h_{pl}(\mathbf{r})\right)$$
(20)

$$\hat{I}_{tl} = \left(\hat{\mathbf{j}}_n + \hat{\mathbf{j}}_p, \nabla h_{tl}(\mathbf{r})\right)$$
(21)

where  $\hat{\mathbf{j}}_n$ ,  $\hat{\mathbf{j}}_p$ ,  $\hat{G}_n(\mathbf{r})$ , and  $\hat{G}_p(\mathbf{r})$  are the estimators for steadystate electron and hole current densities, and generation rates, respectively. It is important to keep in mind that although the choice of test functions in (9)–(12) and (15)–(18) influence the results only to the extent of the numerical precision of the calculation, the same is not true for (19)–(21), in which the choice of test functions plays a critical role. This is because the transport quantities in the integrands of the former groups of equations represent exact solutions of the time-dependent and time-independent defining transport equation, whereas the corresponding quantities in the integrands of the latter group of equations are merely time-averaged estimates from ensemble simulation.

## V. OPTIMIZATION OF TEST FUNCTIONS FOR STEADY-STATE MONTE CARLO TERMINAL CURRENT

The spatial convergence of Monte Carlo estimators is typically far from uniform. This is due to a myriad of different factors including: 1) spatially inhomogeneous fields; 2) thermal gradients; 3) inhomogeneity in material composition, doping level, or strain; or 4) importance sampling and other particle weighting/redistribution techniques. For the case of ensemble simulation, the spatial accuracy of the initial solution is often quite nonuniform. Making use of this fact, we minimize the variance of (19)–(21),  $\langle (\hat{I}_{kl} - \bar{I}_{kl})^2 \rangle$ , k = n, p, t, with respect to the test functions  $h_{kl}(\mathbf{r})$ . Under the assumption of weak interparticle correlation, the resulting set of Euler–Lagrange equations is

$$\nabla \cdot \left\langle \delta \hat{\mathbf{j}}_n \otimes \delta \hat{\mathbf{j}}_n \right\rangle \cdot \nabla h_{nl}^{\text{opt}}(\mathbf{r}) - e^2 h_{nl}^{\text{opt}}(\mathbf{r}) \left\langle \delta \hat{\overline{G}}_n^2(\mathbf{r}) \right\rangle = 0 \quad (22)$$



Fig. 3. Test function for electron drain current evaluation.



Fig. 4. Magnitude of the test function gradient.

$$\nabla \cdot \left\langle \delta \hat{\mathbf{j}}_{p} \otimes \delta \hat{\mathbf{j}}_{p} \right\rangle \cdot \nabla h_{pl}^{\text{opt}}(\mathbf{r}) - e^{2} h_{pl}^{\text{opt}}(\mathbf{r}) \left\langle \delta \hat{\overline{G}}_{p}^{2}(\mathbf{r}) \right\rangle = 0 \quad (23)$$

$$\nabla \cdot \left\langle \delta \hat{\mathbf{j}}_{t} \otimes \delta \hat{\mathbf{j}}_{t} \right\rangle \cdot \nabla h_{kl}^{\text{opt}}(\mathbf{r}) = 0 \quad (24)$$

$$\hat{\mathbf{j}}_{t} = \hat{\mathbf{j}}_{n} + \hat{\mathbf{j}}_{p}$$

$$h_{kl}^{\text{opt}} \Big|_{\Gamma_{t}} = 1, \quad h_{kl}^{\text{opt}} \Big|_{\Gamma_{t}} = 0, \quad j \neq l, \quad h^{\text{opt}} \in H^{1}, \quad k = n, p, t.$$

$$h_{kl}^{\mu\nu}|_{\Gamma_l} = 1, \quad h_{kl}^{\mu\nu}|_{\Gamma_j} = 0, \quad j \neq l, \quad h^{\mu\nu} \in H^1, \quad k = n, p, t.$$
(25)

For simulations using the generation/recombination estimator described in [11] and [12], the *G* terms in (22) and (23) may in most circumstances be dropped. The quantity  $\langle \delta \hat{\mathbf{j}} \otimes \delta \hat{\mathbf{j}} \rangle$  is the position-dependent current density variance tensor. Although its exact form for a given problem requires numerical calculation, one may identify the following useful analytical approximation:

$$\left\langle \hat{\mathbf{j}}_k \otimes \hat{\mathbf{j}}_k \right\rangle_{ij} \approx (\rho_k)^2 \left( v_{T,k,i}^2 - \hat{v}_{k,i}^2 \right) \tau_{c,k} / (N_k t) \delta_{ij}$$
 (26)

which might also be approximated for convenience by the scalar

$$\|\langle \mathbf{j}_k \otimes \mathbf{j}_k \rangle\| \approx (\rho_k)^2 \Big( v_{T,k}^2 - \overline{v}_k^2 \Big) \tau_{c,k} / (N_k t).$$
(27)

The symbols  $\rho_k$ ,  $v_{T,k}$ , and  $\overline{v}_k$  are the charge density, thermal velocity, and mean velocity, respectively, for particles of type k.  $N_k$  and  $\tau_{c,k}$  are the grid-dependent mean type-k particle number and momentum relaxation time. The optimized terminal current estimators for steady-state simulation may then be written as

$$\hat{I}_{nl} = \int \nabla h_{nl}^{\text{opt}}(\mathbf{r}) \cdot \hat{\mathbf{j}}_n \, dV - e \int \hat{G}_n(\mathbf{r}) h_{nl}^{\text{opt}}(\mathbf{r}) \, dV \quad (28)$$

$$\hat{I}_{pl} = \int \nabla h_{pl}^{\text{opt}}(\mathbf{r}) \cdot \hat{\mathbf{j}}_{p} \, dV + e \int \hat{G}_{p}(\mathbf{r}) h_{pl}^{\text{opt}}(\mathbf{r}) \, dV \qquad (29)$$

$$\hat{\bar{I}}_{tl} = \int \nabla h_{tl}^{\text{opt}}(\mathbf{r}) \cdot \left(\hat{\mathbf{j}}_n + \hat{\mathbf{j}}_p\right) dV.$$
(30)



Fig. 5. Drain current convergence time comparison. The simulation was seeded with initial conditions close to the final solution.

It should be kept in mind that solutions of (22)–(24) always yield valid test functions for unbiased estimators in (28)–(30), independent of the exact form of  $\langle \delta \hat{\mathbf{j}} \otimes \delta \hat{\mathbf{j}} \rangle$ . Note also that all solutions  $h_{kl}$  of the Poisson-like equation  $[\nabla \cdot \gamma(\mathbf{r})\nabla + \beta(\mathbf{r}) \cdot \nabla]h_{kl} = 0$  (of which (24) and the simplified forms of (22) and (23) are limiting cases) with the boundary conditions of (25) automatically satisfy the condition  $\sum_{l} h_{kl} = c$ , which is a sufficient condition for global current conservation  $\sum_{l} I_{kl} =$ 0, in both the time-dependent and time-independent forms of the GRST. We further note that in the limit of homogeneous estimator convergence, the function  $h_{tl}^{opt}(\mathbf{r})$  reduces to the solution of the homogeneous Poisson equation, in which case (30) is exactly equivalent to the time-average of the original Ramo–Shockley formula (1).

## VI. EXAMPLE: LDD NMOS DEVICE

We provide as a simple example, results for the the case of a 40-nm n-channel LDD MOSFET, with gate and drain contacts set to 2 V with respect to the source and substrate contacts. A full-band ensemble Monte Carlo charge transport simulation was performed with the simulator Degas [11]. Fig. 1 shows the simulated electron density profile of the LDD device. A scalar version of (24) for the optimized test function was solved using the approximation to the current density variance tensor given by (27), whose solution was then employed in (28) to obtain the terminal currents. This scalar current density variance function is shown in Fig. 2. Figs. 3 and 4 show the test function solution of (24) and its gradient, respectively, the latter of which may be interpreted as a weighting function for the current density. Generally speaking, the greatest contributions to the current estimator come from regions of relatively low density and high mean velocity. Although the degree of improvement over competing techniques is of course example-dependent, we show a comparison of drain current estimator convergence time in Fig. 5, demonstrating the advantage of the optimized test function domain integration technique. In this example, both curves depict cumulative time-averaged data.

## VII. CONCLUSIONS

We have presented a general domain integration method for calculating terminal currents in semiconductor devices, which avoids certain numerical problems associated with evaluating currents along boundary surfaces. This generalized form of the Ramo–Shockley theorem has the advantage of validity in the presence of generation/recombination processes, and one may easily distinguish between electron, hole, and displacement current contributions to the total current. Building upon the time-independent form of these expressions, we have presented and demonstrated a variance-minimizing estimator for the calculation of steady-state terminal currents in ensemble Monte Carlo simulation, offering considerable improvement in estimator accuracy with respect to previous methods, which merely time-average the true terminal currents.

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